## Direct Observation of Stochastic Domain-Wall Depinning in Magnetic Nanowires

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The stochastic field-driven depinning of a domain wall pinned at a notch in a magnetic nanowire is directly observed using magnetic x-ray microscopy with high lateral resolution down to 15 nm. The depinning-field distribution in  $Ni_{80}Fe_{20}$  nanowires considerably depends on the wire width and the notch depth. The difference in the multiplicity of domain-wall types generated in the vicinity of a notch is responsible for the observed dependence of the stochastic nature of the domain-wall depinning field on the wire width and the notch depth. Thus the random nature of the domain-wall depinning process is controllable by an appropriate design of the nanowire.

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For concepts of logic and storage devices utilizing magnetic domain-wall (DW) displacement along a nanowire [1-5], one of the fundamental issues is the precise control of DW motion. The latter is directly linked to the reproducibility of DW propagation, pinning, and depinning. Tunable and repeatable DW motion is important for achieving high performance in DW logic and memory devices [6-9], and the stochastic nature of DW motion is a major challenge to be overcome to apply the scheme of DW motion to next generation memory technologies [10,11]. One attempt to control the DW motion is to manufacture artificial trapping sites within magnetic nanowires [12-17]. Experimental studies on DW dynamics about artificial trapping sites reported so far have been performed by indirect probes like macroscopic hysteresis loops and magnetoresistance measurements [13,14,18,19]. Moreover, the few direct observations have not focused on the in-depth investigation of the stochastic behavior of DW motion around trapping sites in magnetic nanowires [17,20]. Thus, statistical observation of DW propagation in the vicinity of artificial trapping sites in nanowires together with the experimental clarification of the stochastic nature of DW motion have yet remained a scientific challenge.

In this Letter, we report the direct observation of the stochastic behavior of the DW depinning field in notchpatterned Ni<sub>80</sub>Fe<sub>20</sub> (Permalloy) nanowires with different wire widths (w), notch depths ( $N_d$ ), and film thicknesses (t) using magnetic transmission soft x-ray microscopy (MTXM) with a lateral resolution of 15 nm obtained by recent achievements in Fresnel zone plate technology [21]. The MTXM beam line (6.1.2) used to observe the evolution of magnetic DWs is installed at the Advanced Light Source in Berkeley, CA. The experimental setup of this x-ray microscope is described elsewhere in detail [22]. A condenser zone plate with a pinhole close to the sample acts as a linear monochromator, which provides selective x rays, e.g., with an energy corresponding to the Ni  $L_3$  (854 eV) or Fe  $L_3$  (706 eV) absorption edge. Magnetic contrast in MTXM is provided by the x-ray magnetic circular dichroism [23]. Magnetic imaging of the Permalloy nanowires was performed in an in-plane geometry where the wires are mounted under an angle of 60° with respect to the photon beam direction and parallel to the magnetic field. To study DW motion magnetic images in nanowires are recorded with varying external magnetic field generated by a solenoid with field strengths of up to  $\pm 100$  mT at room temperature. The fine magnetic contrast without structural contrast is accomplished by normalization of an image taken at a particular field using an image obtained at a saturation field. The nanowires are prepared on 100 nm thick silicon-nitride membranes by electron-beam lithography and thermal evaporation. For protection of the Permalloy 2 nm aluminum is sputtered, which is oxidized in a pure oxygen atmosphere.

Typical structural images of the wires with triangular notches measured by scanning-electron microscopy (SEM) are shown in Figs. 1(a)-1(c). Magnetic images are taken at the Fe  $L_3$  absorption edge. The wires are initially saturated to positive x direction and then a reversed field is applied to trigger the nucleation and propagation of a magnetic DW along the wire. DW evolution images for 50 nm thick wires with widths of w = 150, 250, and 450 nm are demonstrated in Figs. 1(d)-1(f), where the notch depth is about 50% of the width of each wire. As demonstrated by the experiments shown in Figs. 1(d)-1(f), the magnetic DW is created within the elliptical pad due to its lower shape anisotropy compared to the narrow wire. By increasing the field strength the DW propagates towards the notch. The DW evolution process observed between the pad and the notch is overall identical in all wires with different widths and pad sizes, even though the wire of width w =450 nm with a relatively wide neck shows the distinction that the DW starts leaving toward the notch before the



FIG. 1. (a) Typical SEM image of a 50 nm thick nanowire with a width of 150 nm together with enlarged notch patterns with notch depths of about 30% (b) and about 50% (c) of the wire width. Three representative image sequences of magnetic domain-wall evolution along the hysteresis cycle for wire widths of w = 150 nm (d), 250 nm (e), and 450 nm (f). The magnetic field of the DW evolution pattern is indicated on the lower right.

magnetization reversal of the elliptical pad is fully completed. The DW is pinned at a notch due to the pinning force exerted by this notch and the pinned DW is a tail-totail wall considering saturation (+x) and reversing (-x)field direction [15]. When the external force acting on the pinned DW overcomes the pinning force by the notch, the DW is depinned and propagates to the sharp tip at the right end of the wire where it is annihilated. One can see in Figs. 1(d)-1(f) that the DW depinning field decreases with increasing wire width, which is the consequence of different sizes of DWs governed by different wire widths. The size of the DW trapped at a notch grows as the wire is widened. A bigger DW is energetically unfavorable rather than a smaller DW; thus, the DW depinning field reduces with increasing wire width [13,14,16,19].

To investigate the statistical behavior of the DW depinning field at a notch, we recorded magnetic images in successive hysteretic reversal cycles starting at a fully saturated state of the wire. In repeated measurements we found that the pinning probability of a DW is a function of the wire width. The probability is decreased from about 92% to 75% of the total number of repeated measurements as the wire narrows from 450 to 250 nm. Three representative DW evolution image sequences for wires of w =150, 250, and 450 nm are shown in Fig. 2(a). Here, the color scale indicates the DW pinning and depinning field strengths also indicated on the lower right of each image. Within repeated experiments carried out at the same wire under identical measurement conditions, the DW depinning field shows stochastic behavior, as visualized by various colors. Considering that the depinning field of a



FIG. 2 (color online). (a) Domain-wall evolution patterns taken from three consecutive experiments under identical measurement conditions for wires of width w = 150, 250, and 450 nm. The color scale represents the field when a domain wall is pinned and depinned at a notch. (b) Different domain-wall structures are observed in the vicinity of a notch just before depinning starts. The notch area is enlarged and shows a transverse DW (top) and a vortex DW (bottom), respectively. (c) Domain walls observed by repeated experiments under identical measurement conditions in a 50 nm thick nanowire of w = 250 nm and  $N_d = 50\%$ .

DW in a magnetic nanowire is strongly correlated with the DW structure [12–14,24], the stochastic nature of the DW depinning field can be interpreted to be induced by the generation of various DW types in the vicinity of a notch. We observed that DWs with different micromagnetic structures are depinned at different fields. Figure 2(b) presents detailed pictures of DWs at a notch in the wire of w =250 nm and  $N_d \sim 50\%$ , which reveals that depinning fields are related to the DW structure. In the enlarged images it is visible that two kinds of domain walls exist, either a transverse wall or a vortex wall. It has been observed that the detailed structure and the location of domain walls can be different in repeated measurements in identical microstructures. Figure 3(c) exhibits representative examples for transverse domain walls located differently with unlike micromagnetic structure. Another notable feature observed in repeated experiments is that the depinning field appears different even though the DW pinning field is identical,



FIG. 3 (color online). Distributions of domain-wall depinning fields for (a) 50 nm thick and (b) 30 nm thick nanowires determined from depinning fields taken by repeated experiments with at least 40 repetitions for each wire under identical measurement conditions.

which implies that the DW depinning process is not subordinate to the DW pinning mechanism. This result suggests that complicated phenomena around a notch like the creation of different DW structures and the interaction between the DW and the notch plays the dominant role in the DW depinning process [12,13].

The stochastic nature of the DW depinning field for different notch depths and wire widths has been systematically investigated by determination of the DW depinning-field distribution from depinning events taken in repeated experiments at least 40 times for each wire. The depinning field is measured by sweeping the external field in steps of about 0.5 mT. In Fig. 3(a) the depinning-field distribution for 50 nm thick wires of  $N_d \sim 50\%$  with widths of w = 150, 250, and 450 nm and for wires of  $N_d \sim$ 30% with w = 250 nm are plotted. It can be seen in Fig. 3(a) that the width of the DW depinning-field distribution is found to depend on the wire width and the notch depth. The DW depinning field is widely distributed in wires of width w = 250 nm compared to wires of widths w = 150 and 450 nm. The depinning-field distribution for wires with widths of w = 250 nm becomes narrow as the notch depth decreases from 50% to 30%. We also investigated the statistical distribution of DW depinning fields for wires with a thickness of 30 nm. Depinning-field dis-

depth. The circles (squares) in (a) represent the standard deviations for wires with t = 50 nm,  $N_d = 50\%$  (t = 30 nm,  $N_d = 30\%$ ), respectively. The closed square and circle symbols in (b) exhibit the standard deviations for wires with w = 250,  $N_d = 50\%$ , and t = 30, 50 nm, respectively. The standard deviation of the depinning field was taken from the statistical analysis of more than 40 DW depinning fields for each wire.

FIG. 4 (color online). Standard deviations of the domain-wall

depinning field with respect to (a) wire width and (b) notch

tributions for wires of  $N_d \sim 50\%$  with w = 250 nm and wires of  $N_d \sim 30\%$  with w = 150, 250, and 450 nm are displayed in Fig. 3(b). In the 30 nm thick wires, we focused on the wires with  $N_d \sim 30\%$  instead of  $N_d \sim 50\%$  based on the experimental result for the 50 nm thick wire where the wire with  $N_d \sim 30\%$  exhibits a narrow distribution, which is more preferred for application in DW devices. A similar trend of the influence of the width on the DW depinningfield distribution is also witnessed in the 30 nm thick wire as shown in Fig. 3(b). It is worth pointing out that in Fig. 3 isolated dominant peaks exist in the distributions. This result suggests that the thermal effect on the DW depinning process is not the major cause of the observed fluctuation of DW depinning field, since a Gaussian statistical distribution is expected for thermally activated DW depinning [15,25].

To quantitatively examine the degree of stochastic nature of the DW depinning field with varying wire width and notch depth, we have determined the standard deviation  $\sigma$ of the DW depinning field from statistical analysis of repeated measurements. The standard deviation of the DW depinning field indicates the degree of depinning-field fluctuation. Figure 4 shows the standard deviations as a function of the wire width 4(a) and the notch depth 4(b) for wires of t = 30 and 50 nm. In the case of a 150 nm wide wire with  $N_d \sim 50\%$  and a thickness of 50 nm, the standard deviation of the depinning field is minimized to below 0.7 mT. In the case of a 250 nm wide wire with  $N_d \sim$ 50% and a thickness of 30 nm, the standard deviation of the depinning field is as high as  $\sim$ 5.5 mT. Figure 4 demonstrates that the standard deviation depends sensitively on the wire width and the notch depth, which implies that the stochastic nature of the DW depinning field is decisively influenced by the geometry of the wire. The alteration of the stochastic nature of the DW depinning field with respect to wire width and notch depth is found to be a general tendency irrespective of the wire thickness in Permalloy



wires, although there are slight differences in the absolute value and the variation rate of the standard deviation with the wire width and the notch depth. We have confirmed that the value of the standard deviation of DW depinning-field distribution and its dependence on the notch depth are almost identical in additional samples with the result shown in Fig. 3. Therefore, the stochastic nature of the DW depinning field obtained by statistical measurements with over 40 repetitions is believed to be an intrinsic stochastic nature of DW depinning process around a notch, but is not the result due to sample dependent phenomena. Considering that the depinning field of the DW is strongly related to the DW structure and that the stochastic nature of the DW depinning field is governed by the number of different DW structures that can be generated in a wire, the stochastic nature of the DW depinning field witnessed in the present experiments is presumably caused by the diversity of generable DW structures in the vicinity of a notch. In wires exhibiting narrower fluctuations of the DW depinning field, less types of DWs are accessible compared to wires with strongly fluctuating depinning fields. Thus, we conclude that the key to obtain a reproducible DW depinning process is a single DW type at a notch, which can be achieved by a proper selection of the wire and the notch geometry.

Our experiments report the direct observation of the stochastic nature of the DW depinning field at a notch in Permalloy wires. We find that the stochastic nature of the DW depinning field depends on the wire width and the notch depth. The number of DW types generated in the vicinity of a notch wire has a strong impact on the random nature of the DW depinning field. Our results clearly demonstrate that the stochastic nature of the DW depinning process can be minimized by proper geometrical design of the wires.

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